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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Bruce et al.	Examiner:	Unknown
Serial No.:	09/915,883	Group Art Unit:	2858
Filed:	July 26, 2001	Docket No.:	AMDA.508P
Title:	INTEGRATED CIRCUIT DEFECT ANALYSIS USING LIQUID CRYSTAL		

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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on March 12, 2002.

By:

Erin M. Nichols

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INFORMATION DISCLOSURE STATEMENT (37 C.F.R. §1.97(b))

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

The following items of information may be related to the above-identified application and are brought to the attention of the Examiner: patent application serial number 09/586,518, filed on June 2, 2000; and S.E. Aw *et al.*, "Optical Adsorption Measurements of Band Gap Shrinkage in Moderately and Heavily Doped Silicon" J. Phys: Condens. Matter, vol. 3, pp. 8213-8223 (1991).

This statement should be considered because it is submitted either within three months of the filing date or before the first Office Action of the above-identified application. Accordingly, no fee is due for consideration of the items listed.

No representation is made that a reference is "prior art" within the meaning of 35 U.S.C. §§ 102 and 103 and Applicants reserve the right, pursuant to 37 C.F.R. § 1.131 or otherwise, to establish that the reference(s) are not "prior art." Moreover, Applicants do not represent that a

reference has been thoroughly reviewed or that any relevance of any portion of a reference is intended.

Consideration of the items listed is respectfully requested.

Respectfully submitted,

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Dated: March 12, 2002

By: 

Robert J. Crawford
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